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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplication No.:,

10/812,190

pplicant(s):

Hitoshi HAGIMORI and Kazuhiko ISHIMARU

For:

ZOOM LENS SYSTEM AND IMAGING

DEVICE HAVING THE SAME

Confirmation No.:

2862

Customer No.:

24367

Docket No.:

15162/05730

Filed:

March 29, 2004

Group Art Unit:

2612

Examiner:

Wendy Rae Garber

MAIL STOP AMENDMENT

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on

FEBRUARY 14, 2006

Date of Deposit

TUNG T. NGUYEN

Name of Applicant, Assignee, or Registered

Representative

Signature

FEBRUARY 14, 2006
Date of Signature

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In compliance with the duty of disclosure set forth in 37 C.F.R. § 1.56, Applicants wish to bring the following items to the attention of the Examiner. A copy of each item is enclosed for the convenience of the Examiner.

No representation is made, and no representation is intended, that more relevant material does not exist, or that the order of presentation of this material in any way reflects its relative pertinence. Specifically, this presentation is not an admission that the items listed below are properly citable against the above-identified application.

Submitted herewith is:

(1) Notice of Reasons for Rejection, dated October 27, 2005, for corresponding Japanese Patent Application No. 2004-083257;

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(2) Japanese Unexamined Patent Publication No. (A) 2001-343587 (MINOLTA CO LTD), published December 14, 2001; Together with a copy of an English-language abstract thereof;

- (3) Japanese Unexamined Patent Publication No. (A) 2000-267009 (MINOLTA CO LTD), published September 29, 2000; Together with a copy of an English-language abstract thereof;
- (4) Japanese Unexamined Patent Publication No. (A) 1-191820 (OLYMPUS OPTICAL CO LTD), published August 1, 1989; and
- Japanese Unexamined Patent Publication No. (A) 6-175025(CANON INC), published June 24, 1994; Together with a copy of an English-language abstract thereof.

The above references are cited in item (1), "Notice of Reasons for Rejection", which indicates the degree of relevance found by the foreign office. No copy of document (4) is provided as this document was previously cited in the Information Disclosure Statement filed on March 29, 2004.

As this Supplemental Information Disclosure Statement is being filed prior to the receipt of the first Office Action on its merits, no fee is required. If it should be determined that a fee is required, please charge any required fee (other than the issue fee) during the pendency of this application to Sidley Austin LLP's Deposit Account No. 18-1260. Please credit any overpayment to Deposit Account No. 18-1260.

Respectfully submitted,

Tung 7. Nguyen

Registration No. 42,935 Attorney for Applicants

TTN/Ilb SIDLEY AUSTIN LLP 717 North Harwood, Suite 3400 Dallas, Texas 75201 (214) 981-3478 Direct (214) 981-3300 Main February 14, 2006

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SUPPLEMENTAL APPLICANTS TO THE STATEMENT BY APPLICANTS							First Inventor Group Art Unit		Hitoshi HAGIMORI et al		
3							Examiner Name		Wendy Rae Garber		
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Examiner Initials		F I C E	NUMBER		C O D E	PUB	LICATION DAT	E	TRANSLATION Yes No		
	(2)	JP	2001-343587		Α		12/14/01		ABSTRACT ONLY		
	(3)	JP	2000-267009		Α		09/29/00		ABSTRACT ONLY		
	(5)	JP	6-175025		Α		06/24/94		ABSTRACT ONLY		
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	(1)		of Reasons for Relicon No. 2004-083		on, dated C	ctober 2	7, 2005, for corre	sponding Ja	apanese Pat	ent	
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Examiner
Signature

Date
Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with the next communication to applicant.